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(54) **MONITORING INSTALLATION AND  
MONITORING SYSTEM FOR MONITORING  
AND/OR CONTROLLING AT LEAST ONE  
ELECTRICAL PARAMETER IN AN  
ELECTRICAL SUPPLY SYSTEM, AND  
COMPUTER PROGRAMME**

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**ABSTRACT**

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Described herein is a monitoring installation and a monitoring system for monitoring and/or controlling at least one electrical parameter in an electrical supply system, as well as to an associated computer program.

